Docket No.: MUH-12818

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient Apostage as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Atexandria, VA 22313-1459, on the date indicated below.

Date: June 28, 2006

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.

10/675,049

Confirmation No.: 5871

Applicant

Ioannis Dotsikas

Filed

September 30, 2003

Title

Method and Furnace for the Vapor Phase Deposition of

Components onto Semiconductor Substrates with a Variable

Main Flow Direction of the Process Gas

Art Unit

2818

Examiner

Duang A. Le

Docket No.

MUH-12818

Customer No.

24131

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(c)(1)

Hon. Commissioner for Patents Alexandria, VA 22313-1450

Sir:

In accordance with 37 CFR 1.98 copies of the following patents and/or publications are cited herewith:

Patent Abstract of Japan JP 04-343412 (Harashima Keiichi), dated November 30, 1992;

Patent Abstract of Japan JP 02-074587 (Watabe Junichi, et al.), dated March 14, 1990;

Japanese Office Action dated May 15, 2006.

In accordance with 37 CFR 1.97(e) the undersigned herewith states that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

Respectfully submitted,

Alfred K. Dassler 52,794

Date: June 28, 2006

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/bh

Sheet 1 of 1

FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))

Attorney Docket	l No.:	
MUH-12818		

Applic. No. 10/675,049

Applicant

Ioannis Dotsikas

Filing Date

Group Art Unit

September 30, 2003

281⁸

U.S. PATENT DOCUMENTS

JUL 0 3 2006

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	Α						
	В						
	С						
	D						
	E						
	F			_			
	G			•			
	Н						
	1						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRAI YES	
-	J	04-343412	11/1992	Japan				
	K	02-074587	03/1990	Japan				
	L							
	М							
	N							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

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Р	

EXAMINER DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.